

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shen, et al.	Group Art Unit: 1746
Serial No: 09/507,629	Examiner: Unknown
Confirmation No: 7912	Atty. Docket No.
Filed: February 18, 2000	001945 USA P03/ETCH/SILICON/JB
For: SELF-CLEANING PROCESS FOR ETCHING SILICON- CONTAINING MATERIAL	December 7, 2001 San Francisco, California

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

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TC 1700

Dear Sir:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

Under 37 C.F.R. § 1.97(b) (3), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the first office action.

It is believed that no fee is due for the filing of this Supplemental Information Disclosure Statement. If any fee is due, the Commissioner is hereby authorized to charge payment of any such fees, or credit any overpayment, to Deposit Account No. 10-0258.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to

Box Non-Fee Amendment

By: Rowena Montoya

Dated: 12/7/01

Also, if any Petition is required for the filing of this Supplemental Information Disclosure Statement, such Petition is requested herein.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: December 7, 2001

By: 

Ashok K. Janah

Reg. No. 37,487

Please direct all telephone calls:

Ashok K. Janah
(415)538-1555

Please continue to send all correspondence to:

Applied Materials, Inc.
Patent Department
P.O. Box 450A
Santa Clara, California 95050

Encl

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